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10679844



Title of Invention:

METHODS AND SYSTEMS FOR
INSPECTING RETICLES USING
AERIAL IMAGING AT OFF-
STEPPER WAVELENGTHS

First Named Inventor:

Stan Stokowski

Domestic/Foreign Application:

Domestic Application

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Information Disclosure
Statement

Filing Type:

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3733

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5589-04201

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TRANSMITTAL

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Stylesheet Version v1.1.0

Title of Invention	METHODS AND SYSTEMS FOR INSPECTING RETICLES USING AERIAL IMAGING AT OFF-STEPPER WAVELENGTHS	
Application Number:	10/679844	
Date:	2003-10-06	
First Named Applicant:	Stan Stokowski	
Confirmation Number:	3733	
Attorney Docket Number:	5589-04201	
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Submitted by:	Elec. Sign.	Sign. Capacity
Kevin L. Daffer Registered Number: 34146	Kevin L. Daffer	Attorney
Documents being submitted us-ids	Files 5589-04001IDS2-usidst.xml us-ids.dtd us-ids.xsl	
Comments		

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0



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METHODS AND SYSTEMS FOR INSPECTING RETICLES USING AERIAL IMAGING AT OFF-STEPPER WAVELENGTHS

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First Named Applicant: Stan Stokowski

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Search string: (6636301 or 6614520 or 6529621).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6636301	2003-10-21	Kvamme et al.			
	2	6614520	2003-09-02	Bareket et al.			
	3	6529621	2003-03-04	Glasser et al.			

Signature

Examiner Name	Date